

Ultra Precision Engineering Conference

Attendee List 2016

**Robert Abel**

University of Cambridge

Martin Agnew

Airbus Defence and Space

Temitayo Akindeinde

University of Cambridge

Charlie Barty-King

University of Cambridge

Saif Al-bashir

University of Huddersfield

Adam Bennett

Cranfield University

Peter Brown

The Technology Partnership plc

Wenlong Chang

University of Strathclyde

Ya-Yu Chiang

University College London

Duncan Cooper

Scitech Precision

Neal Croxford

DeBe Lasers Limited

Lily Delimata

University of Cambridge

Robin Devonshire

Faraday Scientific Ltd.

Alexandre Diaz

University of Cambridge

Nikolay Dimov

University College London

Fei Ding

University of Strathclyde

Nathan Formosa

Cranfield University

Will Fowler

University of Cambridge

Silje Fuglerud

CFEL, DESY and NTNU

Nadeem Gabbani

University of Cambridge

Steve Gaston

Advanced Chemical Etching Ltd.

Anthony Gee

University College London

Enza Giaracuni

Cranfield University

Peter Gnauck

Carl Zeiss

David Godwin

Queensgate Instruments

Daniel Gortat

University of Cambridge

Chaoliang Guan

University of Strathclyde

Roy Harris

Coherent (UK) Ltd.

Chris Hole

TTP

Chetan Jagadeesh

City University London

Michael Johnson

Imperial College London

Chris Jones

Micron-Epsilon UK

Julius Knetter

Coherent LaserSystems

Briann Kyte

Alicona Metrology

Gordon Lamb

Cambridge Consultants

Katjana Lange

University of Cambridge

Richard Leach

University of Nottingham

Duo Li

University of Huddersfield

Shan Lou

University of Huddersfield

Xichun Luo

University of Strathclyde

Gary Marriott

Advanced Chemical Etching Ltd.

Karen McGeachy

Laser 2000 (UK) Ltd.

George Meakin

CDT UP

Laurent Michaux

University of Cambridge

Muhammad Mohsin

Aerotech Ltd.

Hussam Muhamedsalih

University of Huddersfield

James Norman

Cranfield University

Martin O'Hara

EPSRC CIM in Ultra Precision

Bill O'Neill

University of Cambridge

Jon Parkins

University of Cambridge

Andrew Payne

University of Cambridge

Michael Porton

UK Atomic Energy Authority

Matt Pryn

University of Cambridge

Hussein Rahman

University of Huddersfield

Derryck Reid

Herriot-Watt University

James Ryley

University of Cambridge

Jyi Sheuan Ten

University of Cambridge

Paul Shore

Cranfield University

Troy Stehr

Bronkhorst UK

Peter Stephenson

Sefton Technologies Ltd.

Helen Swygart

Qiotiq

James Taylor

Goodfellow Cambridge Ltd.

Darran Thomas

H.V.Skan Ltd.

Martin Tolley

STFC Rutherford Appleton Lab.

Zhen Tong

University of Huddersfield

Gary Truett

Xaar

Pooya Ghaderi

University of Cambridge

Shujun Huang

University of Huddersfield

Joris van Nunen

Coherent Europe BV

Sarah Wiczorek

Goodfellow Cambridge Ltd.

Tim Wilkinson

Electrical Engineering Cambridge

Peter Wilkinson

Roadmap Systems

Martin Williams

Schoenthal

Chris Wright

University of Cambridge

Xin Wu

University of Huddersfield

Peter Xia

Cranfield University

Nan Yu

Cranfield University

Wenhan Zeng

University of Huddersfield

Tao Zhang

University of Huddersfield

Hui Zhou

Cranfield University

Ultra Precision Engineering Conference - Exhibitors

Advanced Chemical Etching

Advanced Chemical Etching Ltd (ACE) is the largest independent specialist etching company in the UK, based in Telford, Shropshire in an impressive 20,000 sq ft state-of-the-art facility. Manufacturers of bespoke 2D & 3D precision metal etched components, prototyping and low volume products for aerospace, automotive, electronics & telecommunications, engineering, medical and renewable energy sectors. Continually innovating and developing a number of new manufacturing processes to meet the technical etching needs of their customers. Specialists in the etching of titanium and aluminium. Latest production machinery, a dedicated laboratory and state-of-the-art measuring capability ensures it can produce components in materials, including stainless steel, nickel alloys, copper, beryllium copper, phosphor bronze, brass and, thanks to ground-breaking new processes, aluminium, molybdenum, titanium, nitinol and elgiloy. A process of innovation.

Aerotech

Aerotech is a manufacturer of high quality motors, drives, motion controllers, stages, gantries, gimbals/optical mounts, and custom systems, and is uniquely qualified to assist you with all of your motion control and positioning needs. We provide motion control and positioning solutions for applications in semiconductor, automotive, medical, electronics, photonics, imaging, and other industries. We also manufacture custom, vacuum, and cleanroom compatible components and systems.

We continually upgrade our R&D and manufacturing facilities to remain on the cutting-edge of motion control and positioning technology. Aerotech maintains a state-of-the-art Motion Technology Laboratory, Nano Motion Laboratory, and a recently expanded large system ISO 14644-1 Class 6 (Federal Standard 209E Class 1000) and cell-specific ISO Class 5 (Class 100) cleanroom.

Bronkhorst UK

Bronkhorst UK Limited is a wholly owned subsidiary of Bronkhorst High-Tech BV of the Netherlands and offers local sales and after-sales support, calibration and service facilities, application engineering and user training courses.

Product expertise includes gas and liquid mass flow measurement and control, pressure measurement and control, vapour production and control and primary calibration systems.

The UK Operation was established in 2002 and with quite outstanding success the result has been a 300% increase in both sales turn-over and staffing level. A specialist team has been formed that brings together Degree level education including flow theory, electronics, chemistry and materials engineering with time-served instrumentation placement and world-wide service application. This wealth of knowledge and experience is enhanced with business skills in contracts management and customer care to provide an overall service that is intended to be second to none. Above all else, however, is the commitment to a "can do" ethos that ensures our customers needs and expectations are always exceeded.

Micro-Epsilon

Micro-Epsilon is an innovative company that develops and manufactures high precision sensors and measurement systems for displacement, profile, gap, thickness, distance, vibration, temperature and colour measurement.

With more than 45 years experience, Micro-Epsilon has sensors and measurement applications in almost all industries. Whether it's R&D, NDT, OEM or process control, Micro Epsilon is certain to have a solution for your measurement task.